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Yong-Sun S ** CONTINUING D ** FOREIGN APPI REPUBLIC	n, Ichon-shi, KOREA, REohn, Ichon-shi, KOREA, REOHn, Ichon-shi, KOREA, PATA **********************************	REPUBLI(**** ****** 07/24/200	C OF;					
** 03/22/2004 Foreign Priority claimed			STATE OR COUNTRY KOREA, REPUBLIC OF			TOTAL CLAIMS 20		INDEPENDENT CLAIMS 2
TITLE Method for manufa	cturing shallow trench is	olation in s	emiconductor	device				
RECEIVED N	oto charge/	S: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following:			All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit			